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QUERY CONTROL FORM		RTIS USE ONLY	
Application No. <u>09/591,523</u>	Prepared by <u>NH</u>	Tracking Number <u>05904057</u>	
Examiner-GAU <u>Talbot - 2827</u>	Date <u>3-9-4</u>	Week Date <u>02/16/04</u>	
	No. of queries <u>1</u>	IFW	

JACKET

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|----------------------|------------------------|--------------------|--------------------|
| a. Serial No. | f. Foreign Priority | k. Print Claim(s) | p. <u>PTO-1449</u> |
| b. Applicant(s) | g. Disclaimer | l. Print Fig. | q. PTOL-85b |
| c. Continuing Data | h. Microfiche Appendix | m. Searched Column | r. Abstract |
| d. PCT | i. Title | n. PTO-270/328 | s. Sheets/Figs |
| e. Domestic Priority | j. Claims Allowed | o. PTO-892 | t. Other |

SPECIFICATION

- a. Page Missing
- b. Text Continuity
- c. Holes through Data
- d. Other Missing Text
- e. Illegible Text
- f. Duplicate Text
- g. Brief Description
- h. Sequence Listing
- i. Appendix
- j. Amendments
- k. Other

CLAIMS

- a. Claim(s) Missing
- b. Improper Dependency
- c. Duplicate Numbers
- d. Incorrect Numbering
- e. Index Disagrees
- f. Punctuation
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MESSAGE

PTO-1449: Please either initial or line through citations. Copy provided for reference.

Thank you

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RESPONSE

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Form PTO-1449 (modified)	Atty. Docket No. 47163-00018USD1	Serial No. Not Assigned
List of Patents and Publications for Applicant's INFORMATION DISCLOSURE STATEMENT	Applicant Fujio Kuwako	
Page 1 of 1	Filing Date: Not Assigned	Group: Not Assigned

09/591523
06/09/00

U.S. Patent Documents							
Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date if App.
	A01	5,403,672	04/1995	Urasaki et al.	428	607	
	A02						
	A03						
	A04						
	A05						

Foreign Patent Documents							
Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
	B01	WO97/41713	11/1997	PCT	H05K	3/02	N/A
	B02	Hei 4-3676	1/1992	Japan	H05K	3/46	Abstract
	B03						

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)		
Exam. Init.	Ref. Des.	Citation
	C01	"A Flexible Production Laser System for Blind Via Drilling," Anton Kitai and Jim Morrison, Lumonics, Kanata, Ontario Canada; from brochure <i>Proceedings of the Technical Conference Expo '98</i> , 4 pgs.; 1998
	C02	"CO ₂ Laser Drilling Technology for Glass Fabrics Base Copper Clad Laminate; Morio, Gaku, Hidenori Kimbara Nobuyuki Ikeguchi, Yoshihiro Kato, Mitsubishi Gas Chemical Company, Inc., Toyko, Japan; from brochure <i>Proceedings of the Technical Conference Expo '98</i> , 4 pgs; 1998
	C03	Kestenbaum, Ami, et al., "Laser Drilling Of Microvias In Epoxy-Glass Printed Circuit Boards," <i>IEEE Transactions On Components, Hybrids, and Manufacturing Technology</i> , Volume 13, No. 4, pp. 1055-1062 (December 1990)
	C04	Pargellis, A. N., et al., "Formation of Microvias In Eposy-Glass Composites By Laser Ablation," <i>Optics & Laser Technology</i> , Volume 22, No. 3, pp. 205-207 (June 1990)

EXAMINER:	DATE CONSIDERED:
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INFORMATION DISCLOSURE STATEMENT — PTO-1449 (MODIFIED)

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